Message from the Guest Editors

This proposed Special Issue addresses research on digital image processing methods, e.g., their new applications, increasing their efficacy and efficiency. We invite you to present research on various aspects of image processing: machine learning, object-based analysis, filtration, image enhancement, atmospheric correction, texture analysis, and others in application on various types of remote sensing data: optical, radar, and laser scanning data.

Keywords:

- Digital image processing
- Radiometric correction
- Atmospheric correction
- Filtering
- Machine learning
- Texture analysis
- GEOBIA

Deadline for manuscript submissions: closed (15 April 2022)
Editor-in-Chief

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Message from the Editor-in-Chief

Remote Sensing is now a prominent international journal of repute in the world of remote sensing and spatial sciences, as a pioneer and pathfinder in open access format. It has highly accomplished global remote sensing scientists on the editorial board and a dedicated team of associate editors. The journal emphasizes quality and novelty and has a rigorous peer-review process. It is now one of the top remote sensing journals with a significant Impact Factor, and a goal to become the best journal in remote sensing in the coming years. I strongly recommend Remote Sensing for your best research publications for a fast dissemination of your research.

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